

Electronic Patent Application Fee Transmittal

Application Number:	10628174
Filing Date:	28-Jul-2003
Title of Invention:	PROCEDURE FOR ETCHING OF MATERIALS AT THE SURFACE WITH FOCUSED ELECTRON BEAM INDUCED CHEMICAL REACTION AT SAID SURFACE
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Attorney Docket Number:	8183

Filed as Large Entity

Utility under 35 USC 111(a) Filing Fees

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Extension-of-Time:				
Miscellaneous:				
Printed copy of patent - no color	8001	5	3	15
Total in USD (\$)				1825